

Via Facsimile 703-872-9306

Serial No. 09/825,973

OKI.227

Request for Reconsideration dated October 27, 2004

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT APPLICATION of

Norio Hirashita et al.

Group Art Unit: 2823

Serial No.: 09/825,973

Examiner: J. Maldonado

Filed: April 5, 2001

Confirm. No.: 3710

For: A STRUCTURE OF A FIELD EFFECT TRANSISTOR HAVING METALLIC
SILICIDE AND MANUFACTURING METHOD THEREOF

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OCT 27 2004

REQUEST FOR RECONSIDERATION

U.S. Patent and Trademark Office
220 20th Street S.
Customer Window, Mail Stop AF
Crystal Plaza Two, Lobby, Room 1B03
Arlington, VA 22202

Date: October 27, 2004

Sir:

In response to the Final Office Action dated May 10, 2004, the period for response having been extended three (3) months to November 10, 2004, the following remarks are respectfully submitted in connection with the above-identified application.

Remarks/Arguments begin on page 2 of this paper.